

Electronic Acknowledgement Receipt

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Application Number:	10524525
International Application Number:	
Confirmation Number:	1134
Title of Invention:	Method for selectively removing material from the surface of a substrate, masking material for a wafer, and wafer with masking material
First Named Inventor/Applicant Name:	Martin Hausner
Customer Number:	26875
Filer:	David H. Brinkman/Rhonda Etienne
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed (SB/08)	BEET-09_US_IDS_Form__SB_08 a_3rdSupp.pdf	617000 daaa565e1ce2525021f9511d8aaf70d81c171398	no	4

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2	Foreign Reference	JP7115209.PDF	1602170 7ff8cc1c2b3a361887dc8f993557d13728c582	no	12
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7	Foreign Reference	JP2001345311.PDF	2200078 28e244b1abf0e32af92562512a621ab0db6d122c	no	15
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National Stage of an International Application under 35 U.S.C. 371

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